Notice of References Cited Application/Control No. 10/590,850 Examiner Jennifer Y. Cho Applicant(s)/Patent Under Reexamination FUJISAWA ET AL. Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2004/0198916	10-2004	Nakamura et al.	525/329.4
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NON-PATENT DOCUMENTS

	NON-PATENT DOCUMENTS						
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Sigma-Aldrich Specification Sheet for Potassium Hydroxide ACS reagent					
	V						
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.